

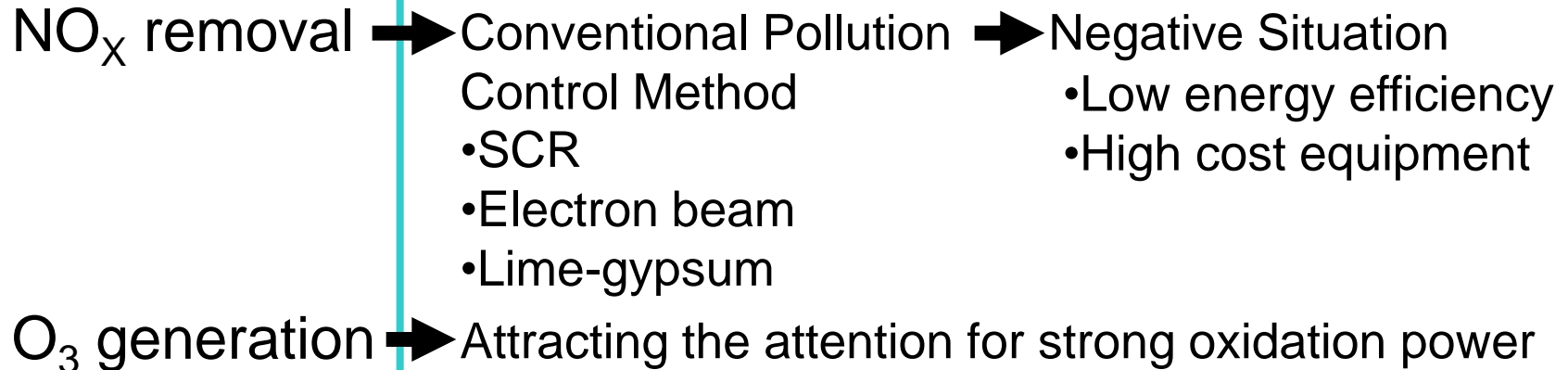


ENERGY TRANSFER EFFICIENCY OF NANO-SECONDS PULSED POWER GENERATOR FOR NON-THERMAL PLASMA PROCESSING

M. Matsuda, D. Wang, T. Matsumoto, T. Namihira
and H. Akiyama

Department of Electrical Engineering and Computer Science,
Kumamoto University

Background



Method

Non-Thermal Electric Discharge Plasmas

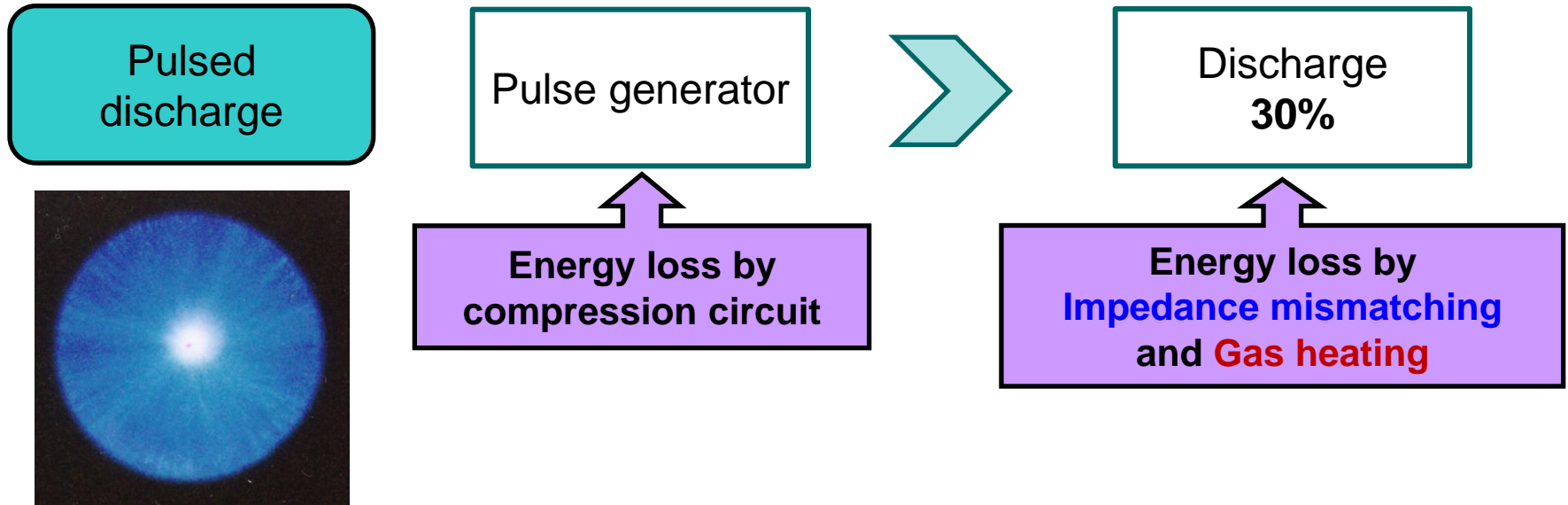
- Dielectric Barrier Discharge (DBD) → 10%
- Corona Discharge → Less than 10%

Low Energy Transfer Efficiency

→ **Non-Thermal Plasma Processing using Pulsed Discharge**

General Pulsed Discharge (Pulse duration > 100ns)

- Pulse discharge system -

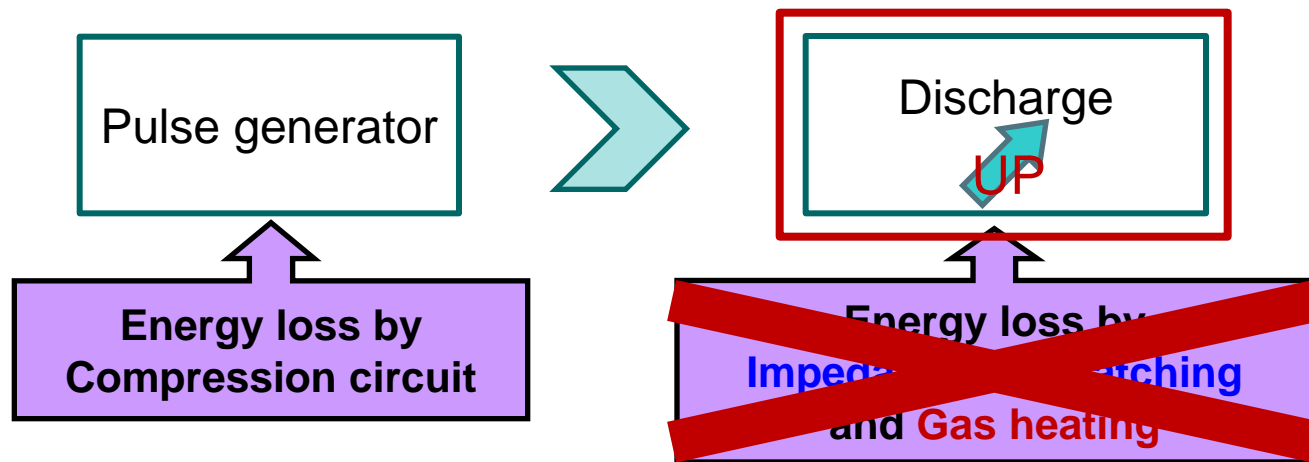
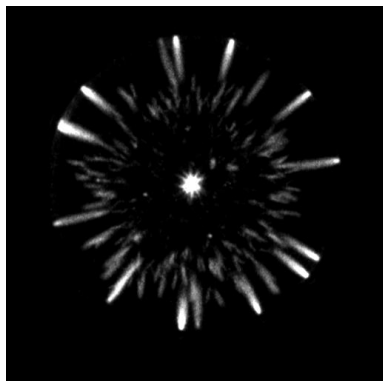


	Pulse discharge plasma		NS pulse discharge plasma
Pulse duration	100 ns		5 ns
Discharge phase	Streamer	Glow	Streamer only
Plasma impedance	5-17 k Ω (L=10 mm)	2 k Ω (L=10mm)	0.2 kΩ (L=1000 mm)
Temperature rise of gas	None	150 K	None

Nano-Seconds (NS) Pulsed Discharge (Pulse duration = 5ns)

- Pulse discharge system -

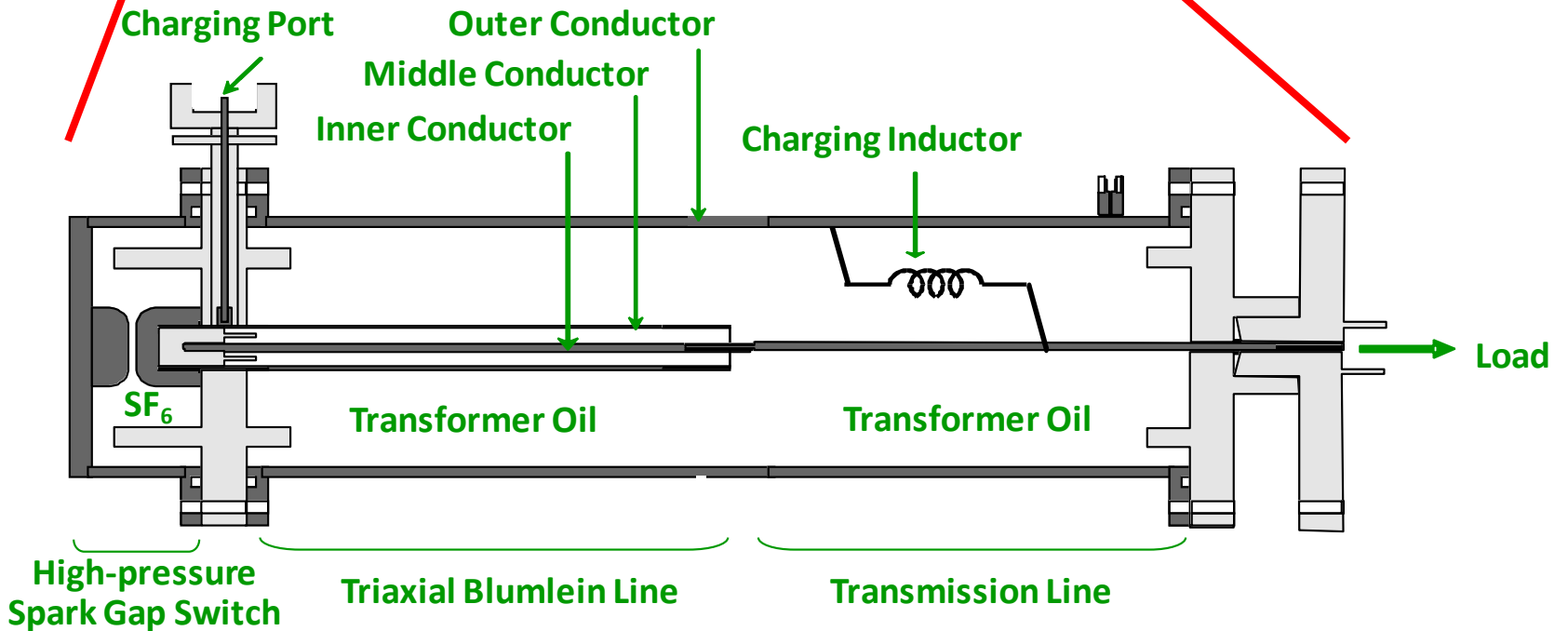
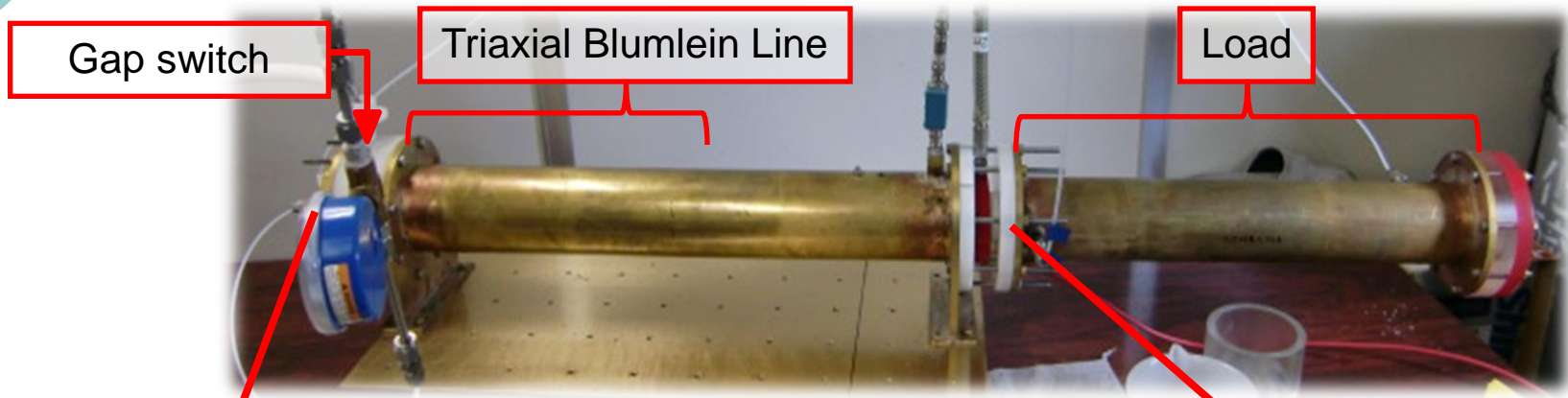
NS Pulsed discharge



To reduce **Impedance mismatching** and **Thermal loss**

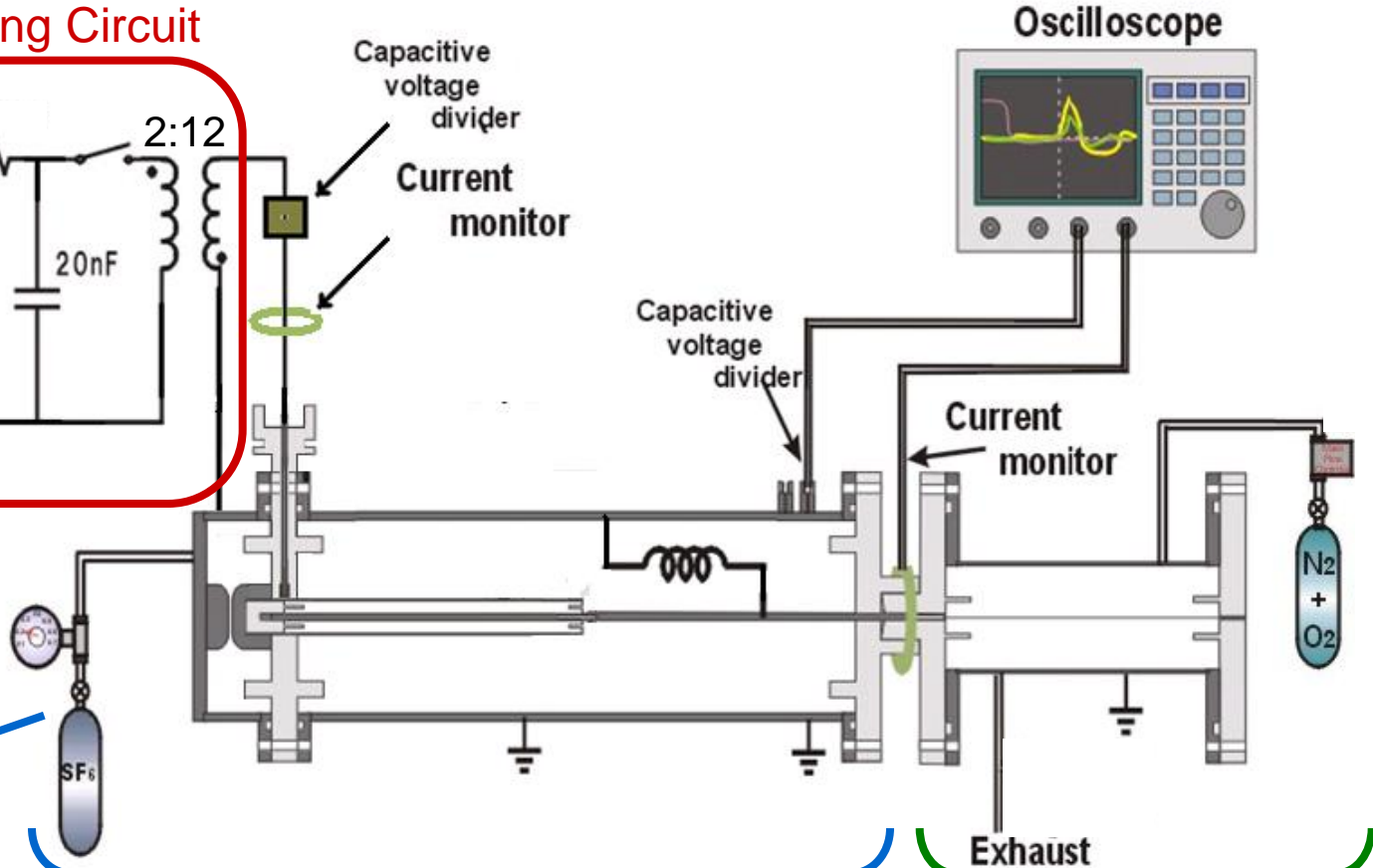
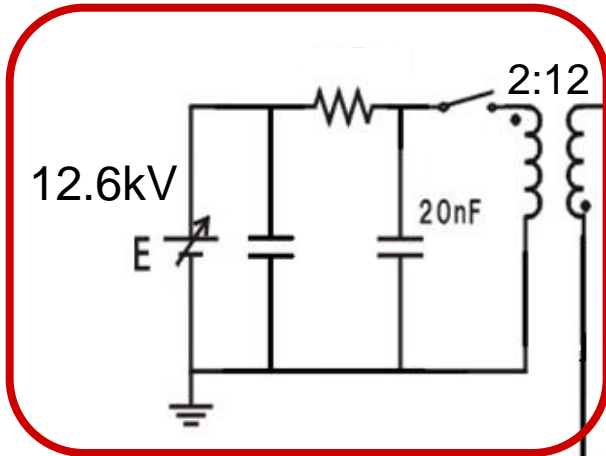
	Pulse discharge plasma		NS pulse discharge plasma
Pulse duration	100 ns		5 ns
Discharge phase	Streamer	Glow	Streamer only
Plasma impedance	5-17 k Ω (L=10 mm)	2 k Ω (L=10mm)	0.2 kΩ (L=1000 mm)
Temperature rise of gas	None	150 K	None

NS Pulsed Generator (NS-PG)



Experimental Set-up

NS-PG Charging Circuit



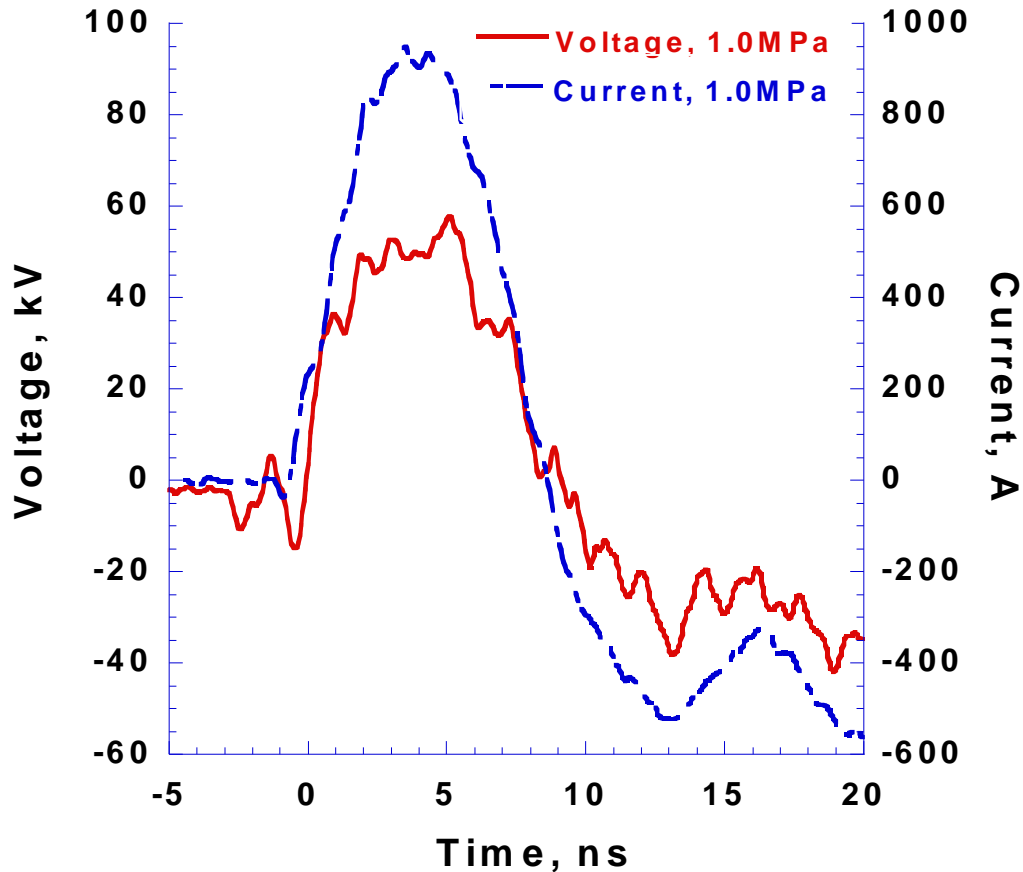
SF₆ gas pressure varied from 0.2Mpa to 1.2Mpa. V_{out} was controlled by varying SF₆ gas pressure.

NS-PG
[Pw = 5ns
Z = 50Ω]

- Low Inductance
- Resistive Load (50Ω)
- Discharge Reactor Load

Low Inductance Resistive Load

- Output Voltage and Current to 50Ω Load -



-Condition-

SF₆ Gas Pressure : 1.0MPa

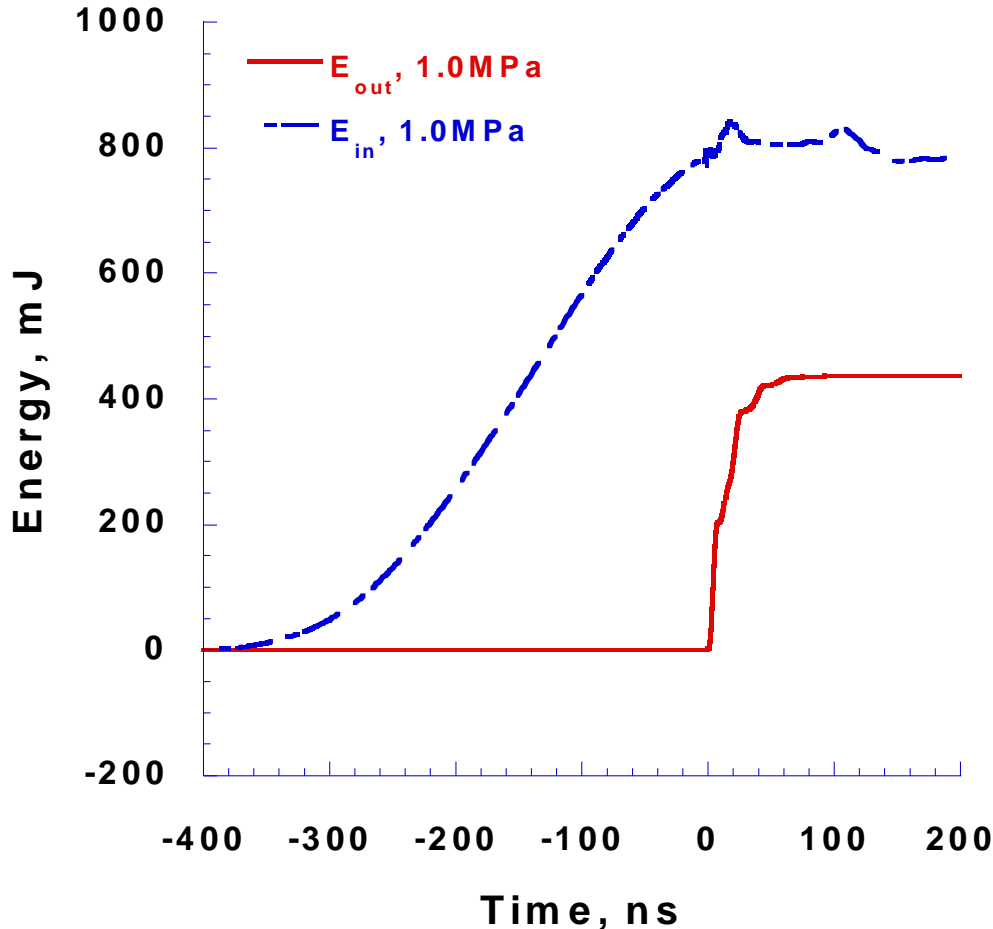
DC Supply Voltage : 12.6kV

Output Polarity : Positive

- Peak Voltage : 57.8kV
(Proportion to Gas Pressure)
- Peak Current : 879.4A
(Proportion to Gas Pressure)
- Full Width at Half Maximum (FWHM) : 5ns

Low Inductance Resistive Load

- Stored energy to NS-PG per pulse, E_{in} ,
and output energy to 50Ω load per pulse, E_{out} -



-Condition-

SF₆ Gas Pressure : 1.0MPa

DC Supply Voltage : 12.6kV

Output Polarity : Positive

$$E_{in} = \int V_{in} \times I_{in} dt \quad (1)$$

$$E_{out} = \int V_{out} \times I_{out} dt \quad (2)$$

V_{in} and I_{in} :

Voltage and Current to NS-PG

V_{out} and I_{out} :

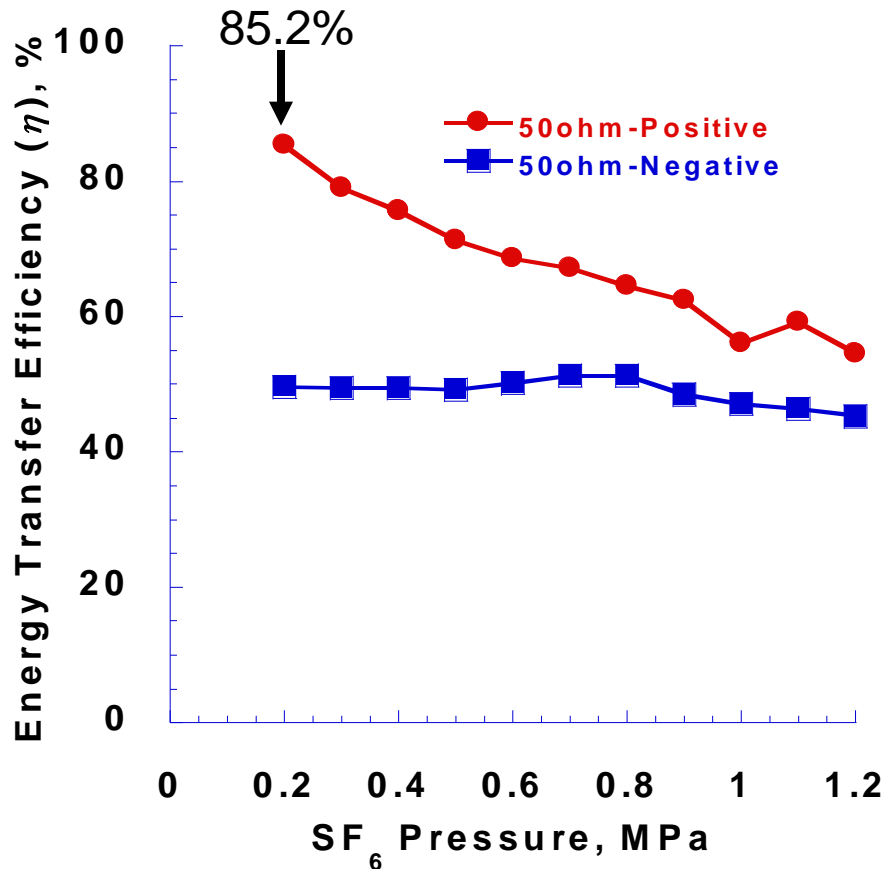
Voltage and Current to load

Energy Transfer Efficiency

$$\eta = \frac{E_{out}}{E_{in}} \times 100 \quad (\%) \quad (3)$$

Low Inductance Resistive Load

- Energy Transfer Efficiency, η -



Output of Positive

➔ **Negative Charge into SGS**

SF₆ Gas Pressure **up**

➔ Voltage Applied to NS-PG System **up**

➔ Corona Loss **up**

➔ Energy Transfer Efficiency **down**

- Switching Loss of SGS
- Impedance Mismatching
(Calculated output impedance is 60Ω)

Output of Negative

➔ **Positive Charge into SGS**

Large Corona Loss occurs even at lower SF₆ gas pressure.

Discharge Reactor Load

- Output Voltage and Current to Discharge Load -

-Condition-

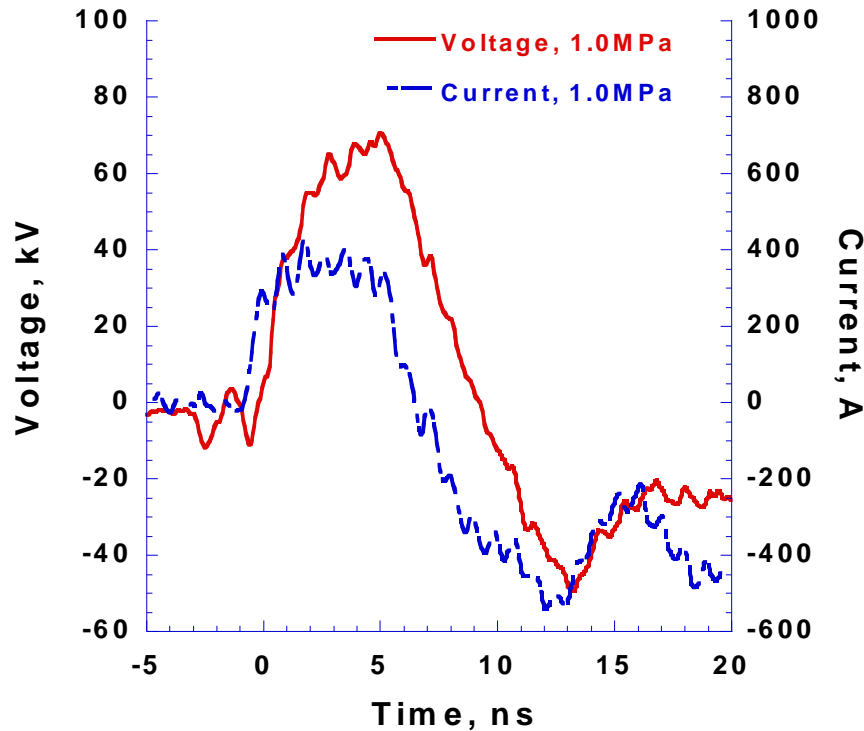
SF₆ Gas Pressure : 1.0MPa

DC Supply Voltage : 12.6kV

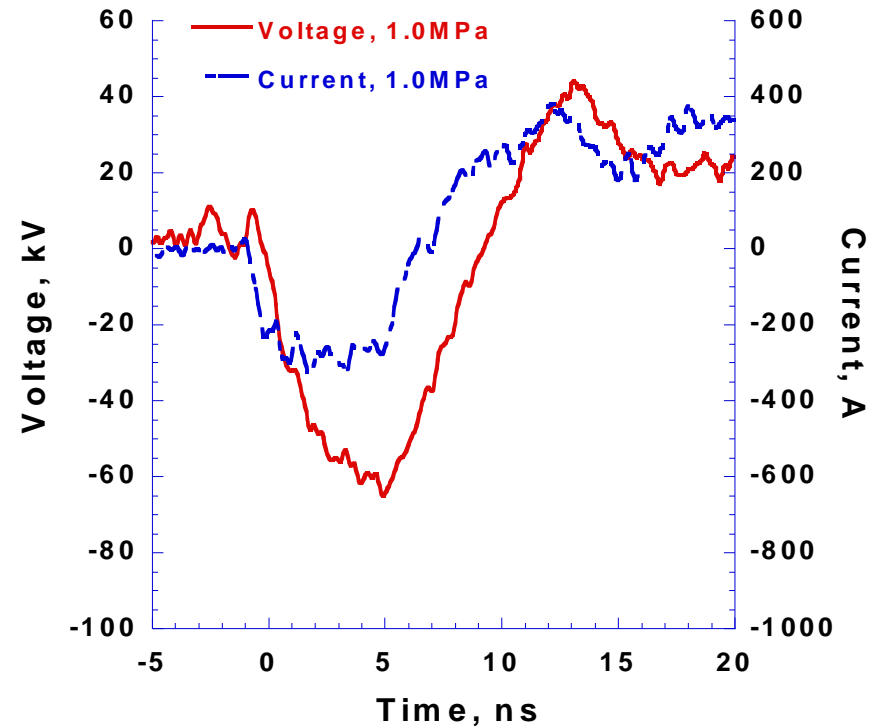
N₂ : 79%, O₂ : 21%

•Peak Voltage : 69.3kV (Proportion to Gas Pressure)

•Peak Current : 374.0A (Proportion to Gas Pressure)



(a) Positive Voltage Polarity



(b) Negative Voltage Polarity

Discharge Reactor Load

- Plasma Impedance of Discharge Load -

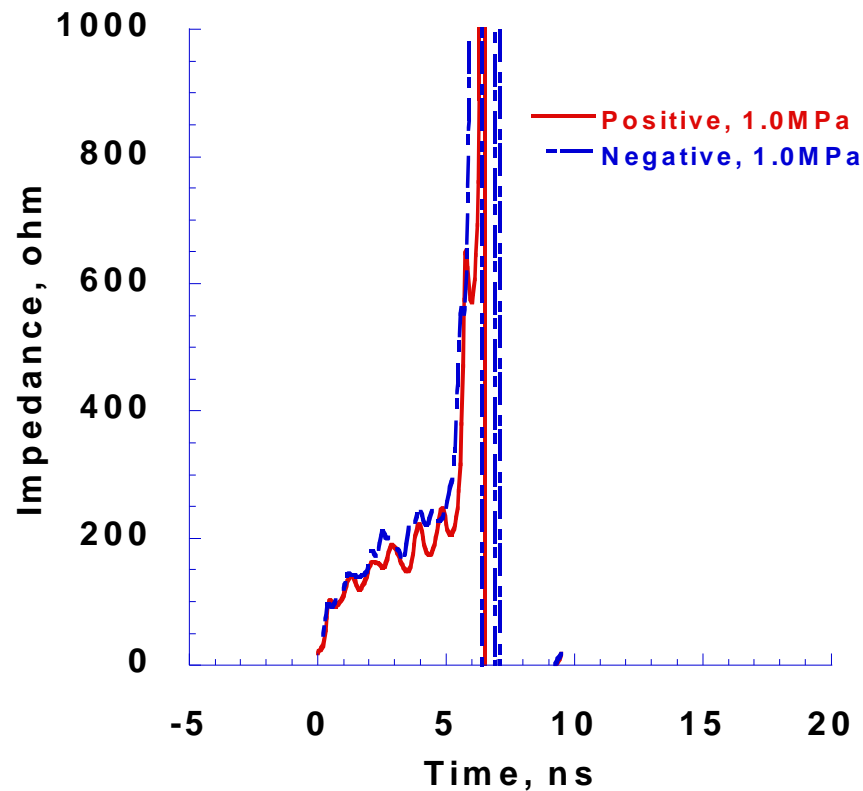
-Condition-

SF₆ Gas Pressure : 1.0MPa

DC Supply Voltage : 12.6kV

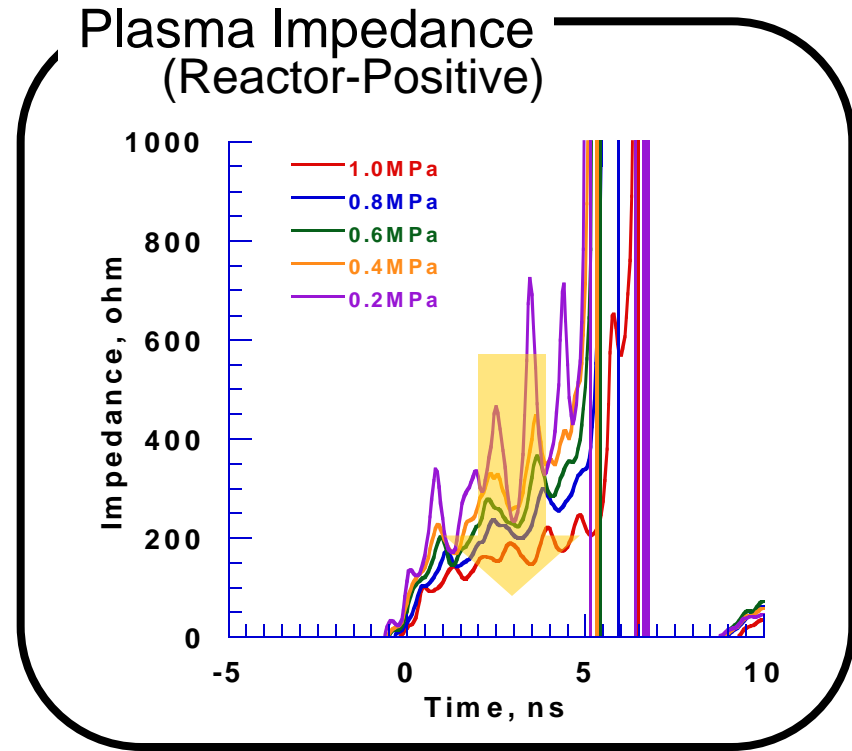
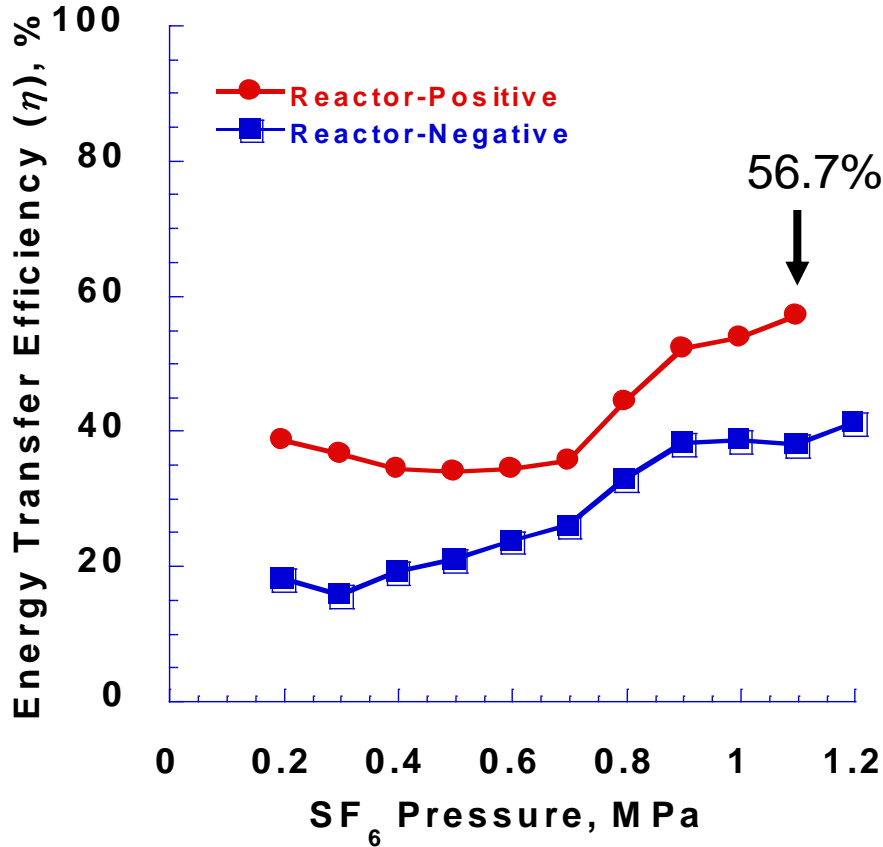
N₂ : 79%, O₂ : 21%

The discharge characters are similar in both voltage polarities.



Discharge Reactor Load

- Energy Transfer Efficiency, η -



- ➡ SF₆ Gas Pressure **up**
- ➡ Plasma Impedance **down**
- ➡ Energy Transfer Efficiency **up**

Conclusion

Energy transfer efficiencies from NS-PG to load were studied on a resistive load and a discharge reactor load, in both cases of positive and negative voltage polarities.

The maximum energy transfer efficiency was **85.2 %** and **56.7 %** in case of resistive load and a discharge reactor, respectively.

Further energy transfer efficiency can be achieved by optimize the configuration of discharge reactor.

Load		Low inductance 50 Ω resistor		Discharge reactor	
Positive	$V_{out-peak}$	21.5 kV	59.2 kV	20.4 kV	74.4 kV
	E_{out}/E_{in}	85.2 %	59.2 %	38.4 %	56.7 %
Negative	$V_{out-peak}$	-23.0 kV	-55.6 kV	-26.2 kV	-68.3 kV
	E_{out}/E_{in}	49.6 %	46.4 %	17.8 %	37.9 %

 **up** Goal
100%



Thank you for your attention.